

METHOD FOR FORMING A JUNCTION REGION OF A SEMICONDUCTOR DEVICE  
Inventor: Yu-Kun CHEN  
Docket No. 4425-344

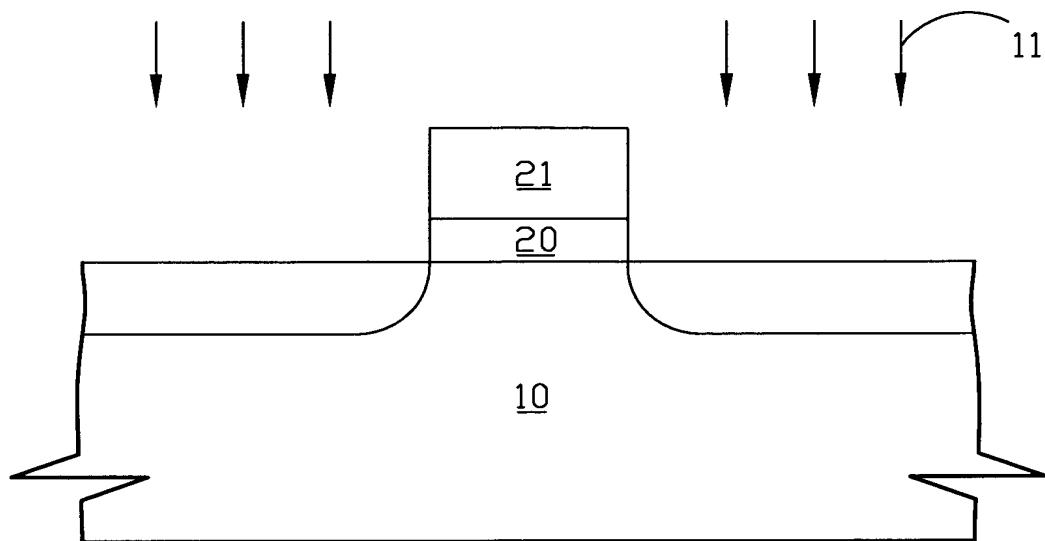


FIG.1A

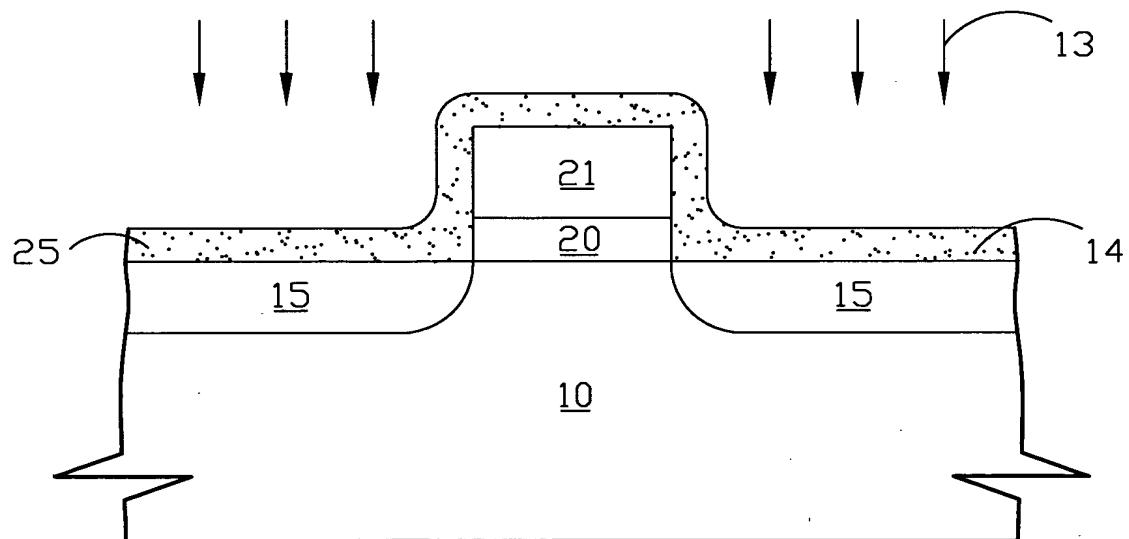


FIG.1B

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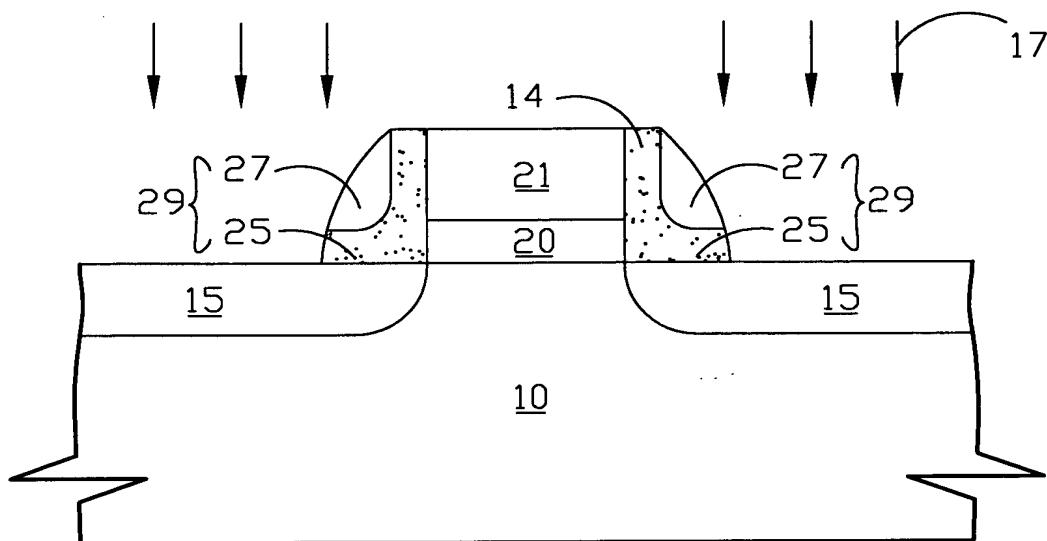


FIG.1C

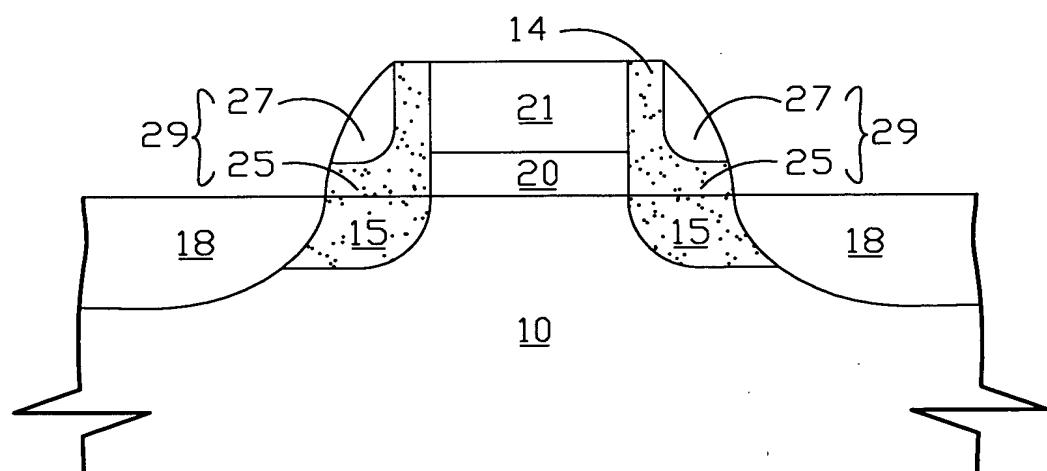


FIG.1D

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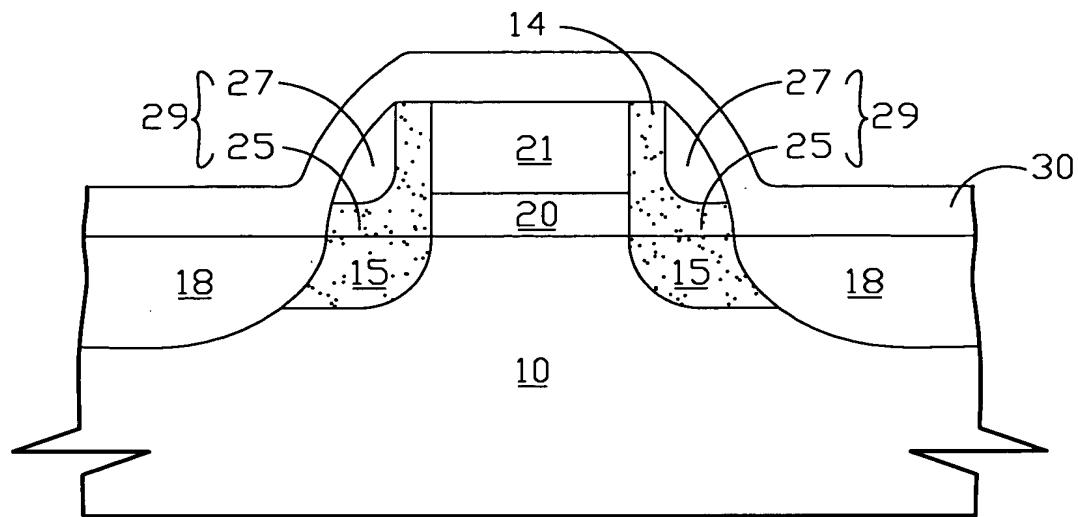


FIG.1E

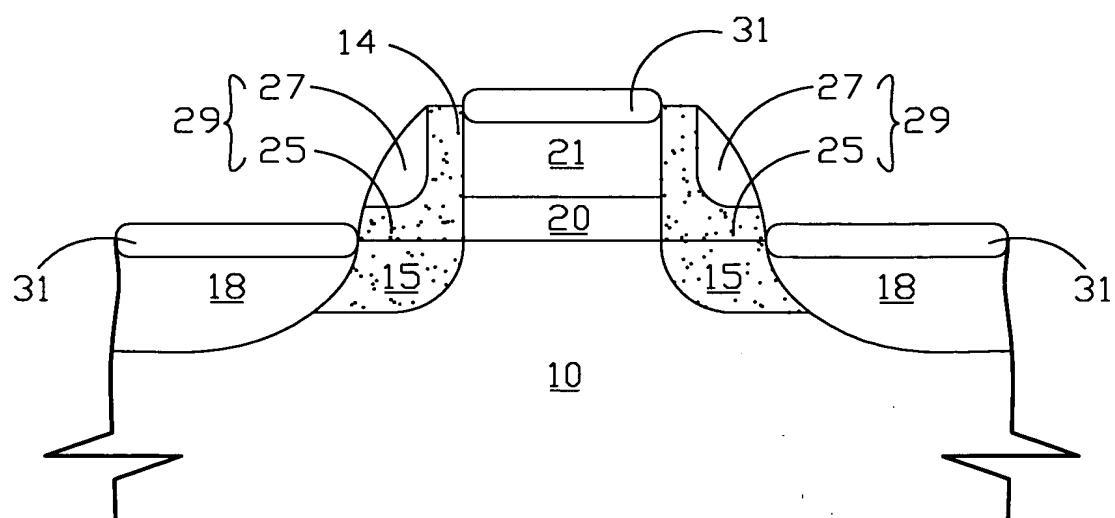


FIG.1F